

Form PTO-1449 U.S. Department of Commerce
Patent and Trademark Office

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Atty. Docket No.	Serial No.
FSI0052/US/2	10/695,843
Applicant	
Collins et al.	
Filing Date	Group
October 29, 2003	2812- 2823

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Lee</i>	4,688,918	08/1987	Suzuki et al.			
	4,787,332	11/1988	Geisel et al.			
	4,797,834	01/1989	Honganen et al.			
	4,932,353	06/1990	Kawata et al.			
	4,979,641	12/1990	Turner			
	4,989,756	02/1991	Kagamihara et al.			
	5,056,034	10/1991	Rucki et al.			
	5,058,043	10/1991	Skeirik			
	5,066,616	11/1991	Gordon			
	5,097,424	03/1992	Ginevri et al.			
	5,109,347	04/1992	Quick, Jr. et al.			
	5,127,362	07/1992	Iwatsu et al.			
	5,260,174	11/1993	Nakazawa et al.			
	5,277,333	01/1994	Shimano			
<i>Lee</i>	5,366,757	11/1994	Lin			

U.S. PUBLISHED PATENT APPLICATION DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Lee</i>	2003/0075555	04/2003	Mekias			09/2002

FOREIGN PATENT DOCUMENTS

Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No
<i>Lee</i>	5-144721	09/1993	Japan			Abstract
<i>Lee</i>	4-94525	03/1992	Japan			Abstract
<i>Lee</i>	3-178123	08/1991	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

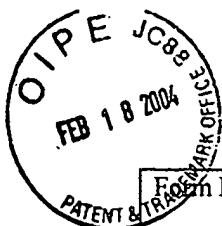
<i>Lee</i>	Gürer, et al., "Model-based adaptive process control: A CD-control example," <u>Solid State Technology</u> , pp. 205-212, July 1998
<i>Lee</i>	Gürer, et al., "Line Width Control Via Adaptive Process Control in Lithography," <u>SEMICON Korea Technical Symposium</u> , pp. 205-218, 1998

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Karen May Lee

3/8/005

Paper No. : 021804



<p>TRADEMARK PTO-1449</p> <p>U.S. Department of Commerce Patent and Trademark Office</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p>	<p>Atty. Docket No.</p> <p>FSI0052/US/2</p> <p>Applicant</p> <p>Collins et al.</p>	<p>Serial No.</p> <p>10/695,843</p>
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Karen M. Linn

3/8/2015

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>Lee</i>	5,985,357	11/1999	Sanada				
<i>Lee</i>	6,383,948	05/2002	Kitano et al.				
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<i>Lee</i>	2002/0124798 A1	09/2002	Kitano et al.			12/2000	
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Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No	
<i>Lee</i>	EP 0 829 767 A1	03/1998	EP				
<i>Lee</i>	EP 0 863 538 A2	09/1998	EP				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Lee</i>	PCT/US 03/29168 PCT International Search Report, mailed 02/27/2004.						

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Paul Ming Lin

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